

Docket No. 198322US-2 CONT

IN RE APPLICATION OF: Takahiro HORIKOSHI, et al.

SERIAL NO: 09/680,513

FILED: October 6, 2000

FOR: EXPOSURE METHOD, EXPOSURE APPARATUS AND MAKING METHOD...

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

Transmitted herewith is an amendment in the above-identified application.

- No additional fee is required
- Small entity status of this application under 37 C.F.R. §1.9 and §1.27 is claimed.
- Additional documents filed herewith: Marked-Up Copy, Request for Extension of Time (3 months), Information Disclosure Statement, PTO-1449

The Fee has been calculated as shown below:

CLAIMS	CLAIMS REMAINING		HIGHEST NUMBER PREVIOUSLY PAID	NO. EXTRA CLAIMS	RATE	CALCULATIONS
TOTAL	49	MINUS	58	0	× \$18 =	\$0.00
INDEPENDENT	12	MINUS	11	2	× \$84 =	\$84.00
		<input type="checkbox"/> MULTIPLE DEPENDENT CLAIMS			+ \$280 =	\$0.00
						\$84.00
		<input type="checkbox"/> Reduction by 50% for filing by Small Entity				\$0.00
		<input type="checkbox"/> Recordation of Assignment			+ \$40 =	\$0.00
						TOTAL
						\$84.00

- A check in the amount of \$ is attached.
- Please charge any additional Fees for the papers being filed herewith and for which no check is enclosed herewith, or credit any overpayment to deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.
- If these papers are not considered timely filed by the Patent and Trademark Office, then a petition is hereby made under 37 C.F.R. §1.136, and any additional fees required under 37 C.F.R. §1.136 for any necessary extension of time may be charged to Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.



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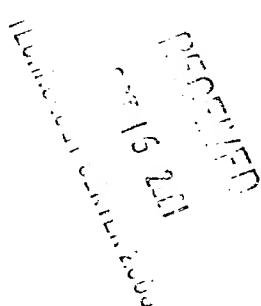
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198322US-2 CONT



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IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF:

Takahiro HORIKOSHI, et al. : GROUP ART UNIT: 2851

SERIAL NO: 09/680,513 ✓ :

FILED: October 6, 2000 : EXAMINER: K. BROWN

FOR: EXPOSURE METHOD, EXPOSURE
APPARATUS AND MAKING METHOD...

AMENDMENT

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

Responsive to the Office Action dated April 11, 2001, please amend the above-identified

application as follows:

IN THE CLAIMS

Please cancel claims 2, 3, 7-13, 25-27, 36-39, 43, 47 and 48 without prejudice.

Please amend claims 1, 4-6, 14, 22, 24, 28, 29, 32, 34, 35, 42 and 46 as shown in the marked-up copy to read as follows:

July 18
1. (Amended) An exposure method performed by an exposure apparatus to transfer a pattern illuminated with exposure light from a light source onto a substrate, said method comprising:

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photodetecting a part of said exposure light in an optical path of said exposure light; setting a measurement interval of a transmittance of said optical system which is arranged between a position of photodetecting a part of said exposure light and said substrate

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